

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2812
Examiner: Not yet assigned

IN RE: PATENT APPLICATION OF:

Applicants: Noriko TOMITA et al.
Serial No.: 10/660,490
Filed: September 12, 2003
For: SEMICONDUCTOR SUBSTRATE
SURFACE PROTECTION METHOD
Docket No.: OHG-135

)
)
) **INFORMATION**
) **DISCLOSURE**
) **STATEMENT**
)
)
)
)

December 12, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is an information disclosure statement submitted in compliance with the timing requirements of 37 C.F.R. §1.97(b) (1) and (b)(3), i.e., within three months from the filing of the application and prior to a First Office Action on the Merits.

Attached is a copy of a Japanese publication. Any relevance of this publication can be gleaned from the corresponding cited U.S. patent. The documents are listed on the attached Form PTO-1449.

Since this Information Disclosure Statement is being filed before the First Office Action, no certification or fee is required, and the requirements of 37 C.F.R. §§1.97 and 1.98 are deemed to be fully met as to all documents submitted. Consideration of the submitted documents is respectfully requested.

Respectfully submitted,

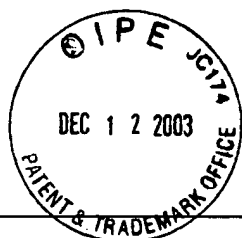
Robert H. Berdo, Jr.
Registration No. 38,075
RABIN & BERDO, PC
Customer No. 23995
Telephone: 202-371-8976
Facsimile: 202-408-0924

RHB:crh

FEE ENCLOSED: \$0
Please charge any further
fee to our Deposit Account
No. 18-0002

FORM PTO-1449

INFORMATION DISCLOSURE STATEMENT

Atty. Docket:
OHG-125Application No.:
10/660,490Applicant:
Noriko TOMITA et al.Filing Date:
September 12, 2003Group Art Unit:
2812

U.S. PATENT DOCUMENTS

| Examiner Initial | | Document Number | Date | Name | Class | Sub-Class | Filing Date |
|------------------|----|------------------|-----------------|---------------------|-------|-----------|-------------|
| | AA | 6,165,956 | 12/26/00 | Zhang et al. | | | |
| | AB | | | | | | |
| | AC | | | | | | |
| | AD | | | | | | |
| | AE | | | | | | |
| | AF | | | | | | |
| | AG | | | | | | |
| | AH | | | | | | |

FOREIGN PATENT DOCUMENTS

| | | Document Number | Date | Country | Class | Sub-Class | Trans - lation |
|--|----|--------------------|-----------------|--------------|-------|-----------|----------------|
| | AI | 2001-521285 | 06/11/01 | Japan | | | No |
| | AJ | | | | | | |
| | AK | | | | | | |
| | AL | | | | | | |
| | AM | | | | | | |

OTHER (Including Author, Title, Date, Pertinent Pages, etc.)

| | | |
|--|----|--|
| | AN | |
| | AO | |

Examiner

Date Considered

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.